

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Confirmation No.: 5377

Makiko KITAZOE, et al

Art Unit: 1712

Application No.: 10/591,905

Examiner: Keath T. CHEN

Filed: November 6, 2006

Attorney Docket No.: 029567-00010

For: SELF-CLEANING CATALYTIC CHEMICAL VAPOR DEPOSITION APPARATUS  
AND CLEANING METHOD THEREOF

**AMENDMENT FILED WITH REQUEST FOR CONTINUED EXAMINATION (RCE)**

**MAIL STOP RCE**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

August 3, 2010

Sir:

In reply to the May 4, 2010, Office Action, and upon grant of the attached Request for Continued Examination (RCE), please amend the above-identified application as follows:

Amendments to the claims, as reflected in the listing of claims, being on page 2;  
and

Remarks begin on page 8.